



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

TAKEHIKO FUJITA, *et al.*

Serial No.: 10/532,878

Filed: April 28, 2005

For: THERMAL PROCESSING UNIT AND THERMAL  
PROCESSING METHOD

**Confirmation No. 9324**

Art Unit: 1792

Examiner: Ram N. Kackar

Atty. Dckt: 033082R251

**RESPONSE UNDER 37 C.F.R. 1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Mail Stop: Amendment**

Dear Sir:

This is in response to the Office Action mailed September 2, 2008, to which the time for response is set to expire December 2, 2008. A one-month extension of time is being filed herewith such that the response due date is January 2, 2009. The pending claims, claims 1-7 and 9-12, were rejected. Reconsideration and entry of the following amendments are respectfully requested.

Amendments to the Claims begins on page 2 of this paper.  
Remarks begin on page 8 of this paper.